IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Markus Schwambera, et al.
Serial No Pending	January 9, 2004
Title of Application:	Process Chamber with a Base with Sectionally Different Rotational Drive and Layer Deposition Method in Such a Process Chamber

Mail Stop Patent Application Commissioner for Patents Post Office Box 1450 Alexandria, VA 22313-1450

Cover Sheet For Three Sheets Of Drawings

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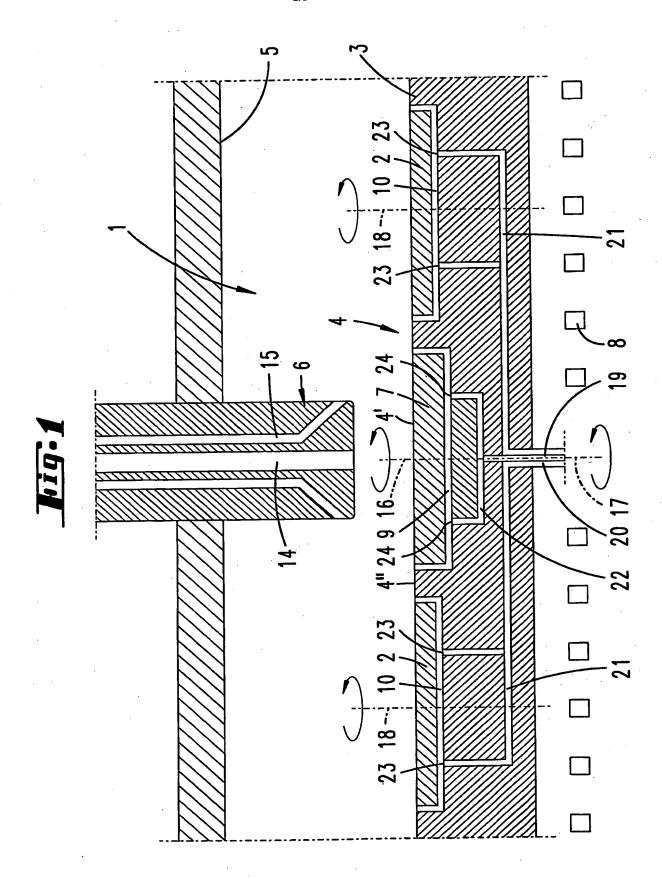


Fig. 2

